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Substitute for form 1449A/PTO				Complete if Known	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>				Applicant Number	10/620004
				Filing Date	
				First Name of Inventor	David T. Marquies
				Art Unit	
				Examiner Name	
Sheet	1	of	2	Attorney Docket Number	HSJ920030168US1

[illegible][illegible]

Examiner Signature	<i>[Signature]</i>	Date Considered	3/3/05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 See Kind's Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO		<b>Compleat if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		Applicati n Number	10/10/2004
		Filing Date	
		First Named Invent r	David T. Margulies
		Group Art Unit	
		Examiner Name	
Sheet 2 of 2	Attorney Docket Number	HSJ920030168US1	

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
ad		S. E. Lambert, et al., "Reduction of Media Noise in Thin Film Metal Media by Lamination", IEEE Transactions on Magnetism, Vol. 26, No. 5, September 1990, pp. 2706-2709	
✓		D. Weller et al., "High Ku materials approach to 100 Gbits/in <sup>2</sup> ", IEEE Transactions on Magnetism, Vol. 36, Issue 1, Jan. 2000, pp 10 -15	
✓		"Data Recording at Ultra High Density", IBM Technical Disclosure Bulletin, Vol. 39, No. 7, July 1996, p. 237	
ad		"Thermally-Assisted Magnetic Recording", IBM Technical Disclosure Bulletin, Vol. 40, No. 10, October 1997, p. 65	

Examiner Signature	<i>[Signature]</i>	Date Considered	3/3/05
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